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Serial No. 14	/339,058			
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REEL: 034415 FRAME: 0677

CONFIRMATORY LICENSE

Title of Invention: METHOD AND SYSTEM FOR CONTINUOUS ATOMIC LAYER

DEPOSITION

Inventors: Angel Yanguas-Gil, Jeffrey W. Elam, Joseph A., Libera

Patent Application Serial No.: 14/339,058 Filing Date: July 23, 2014

Patent Number: Issue Date:

Contractor: UChicago Argonne, LLC DOE Contract No.: DE-AC02-06CH11357

DOE Case No.: S-134,578 ANL Case No.: ANL-IN-13-042

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